

Beam monitoring area

- Beam shutter
- Slits 1
- « Fluo » detector
- « 2 diodes » detector
- Wire detector
- Currently in Grenoble
- Tested

Beam size selection and cleaning

- Slits 2 et 3
- Currently in Grenoble
- Tests in progress

Spectral selection

- Monochromator
- To be designed and realized

Security / Radioprotection

- Security Beam shutter
- Connecting tube Igloo – Hall D1
- Installed in Igloo
- Tested

Sample and mono positioning / Analysis

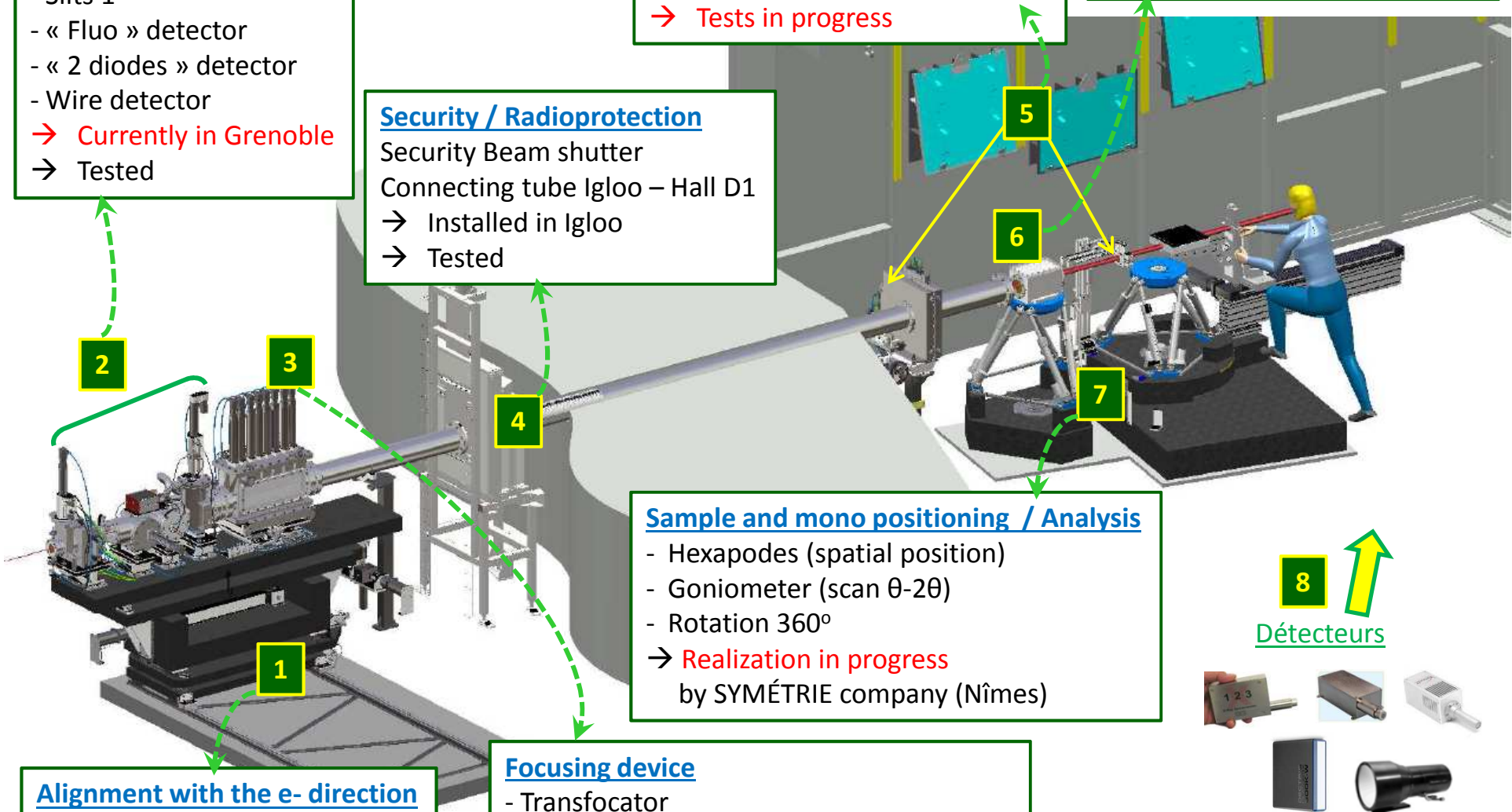
- Hexapodes (spatial position)
- Goniometer (scan θ - 2θ)
- Rotation 360°
- Realization in progress by SYMÉTRIE company (Nîmes)

Focusing device

- Transfocator
- Currently in Grenoble
- Assembly in progress (almost finished)

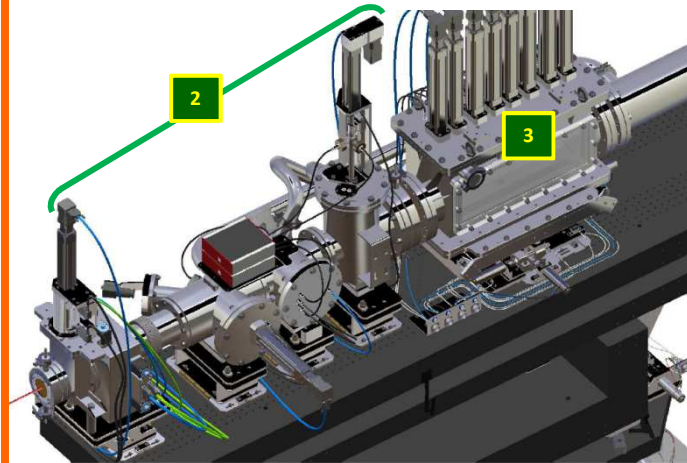
Alignment with the e- direction

- Motorized Table
- Floor rails for retraction Table1
- Installed in Igloo
- Almost fully tested

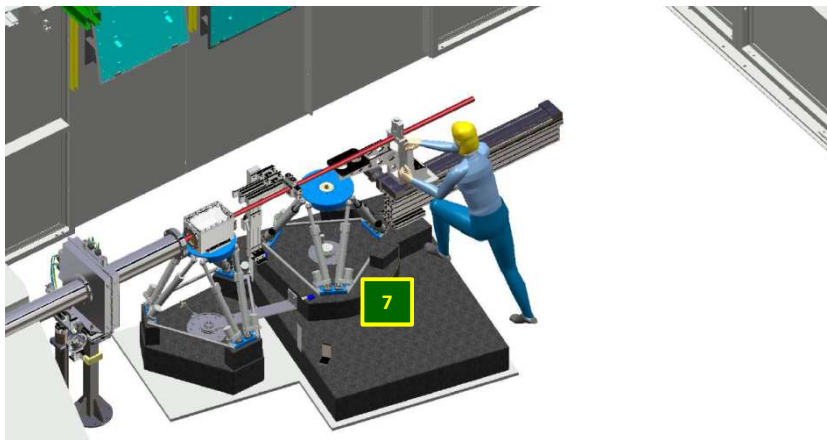


Technical aspects

Around January 2019, bring back the material **2** and **3** from Grenoble to Orsay, install it, connect it and test again, in situ, the vacuum and the control/command.



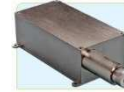
June 2019, delivery of the system **7** at Orsay. SYMÉTRIE will install the device in the X-hutch adjust it, train the staff.



1 CdTe detector

(25mm², integrated electr.)
 → At Orsay
 → Tested

Beam
 characterization
 (spectral flux)



1 calibrated Si diode

→ **To be ordered** (Canberra)

8



2 SDD detectors

(25 mm² + FalconX electr.)
 → Currently 1 in Grenoble
 1 at LAMS
 → Tested

Fluorescence
 (high count rate)

288 K pixels
 250x33 mm²



1 CdTe 2D pixel detector

→ Realized (Dectris)
 → Problem of power supply
 during the commissioning
 end of May in Grenoble
 → **Back to Dectris for fixing**

Diffraction
 θ -2 θ

16 M pixels
 55x55 mm²



1 médical 2D detector

(scintill + CMOS camera)
 → **Realization in progress**
 (Photonic Science)

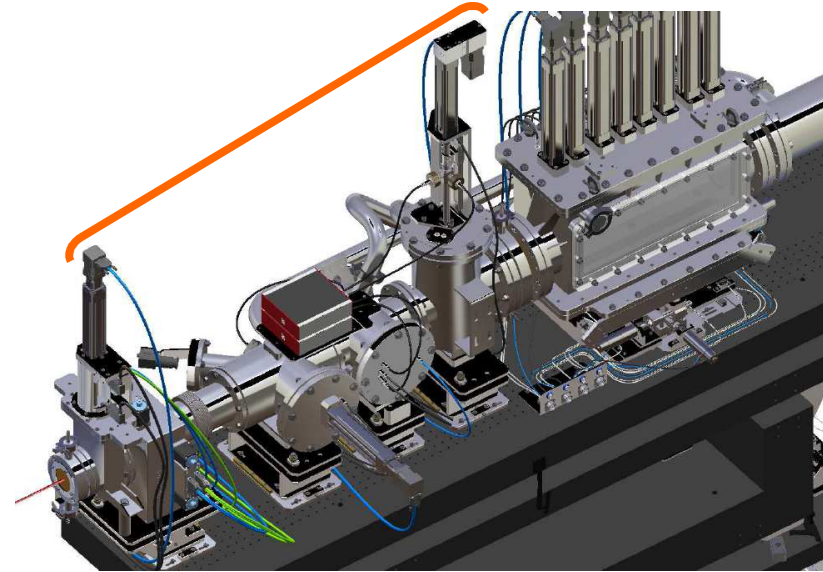
Imaging
 (small
 spatial
 resolution)

Commissioning

1.

During the **e- commissioning** (LINAC, Trans. line and SR) (**without e-/laser interactions**), we will study the **background signals in our three detectors**.

We will perform these background studies for different openings of the **entrance slits** and/or with the X-line **beam shutter** closed or open.

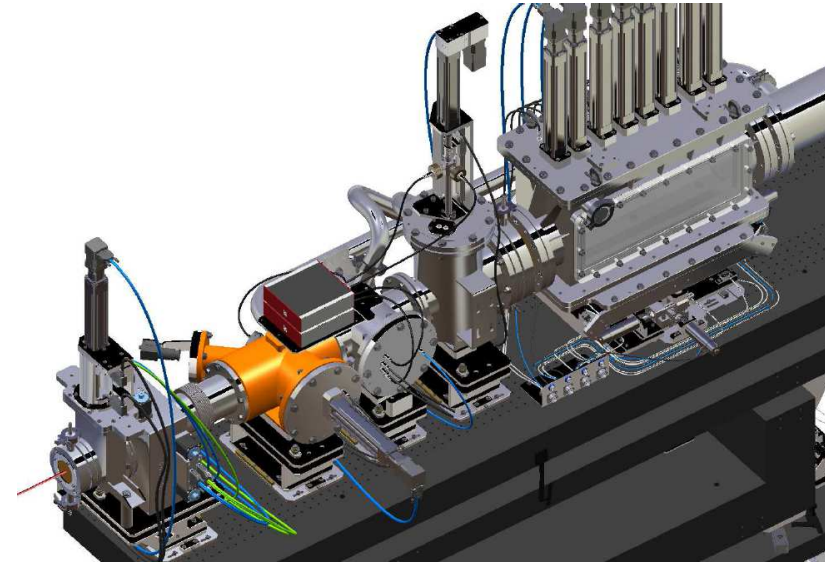


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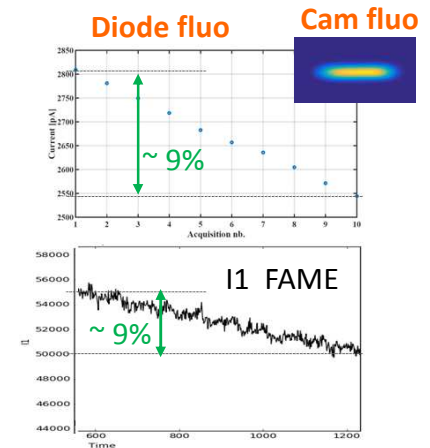
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2.

Once both e- and FP cavity laser will be **ready** for Compton interactions, we will constantly survey the **Si-PIN diode signal of the “Fluo detector”** during the phase of **spatial and temporal matching of the e- and laser**. As soon as we will see an **increase of the current**, we will sabre the champagne and optimize the matching by looking for the machine operating point giving the maximum diode current.

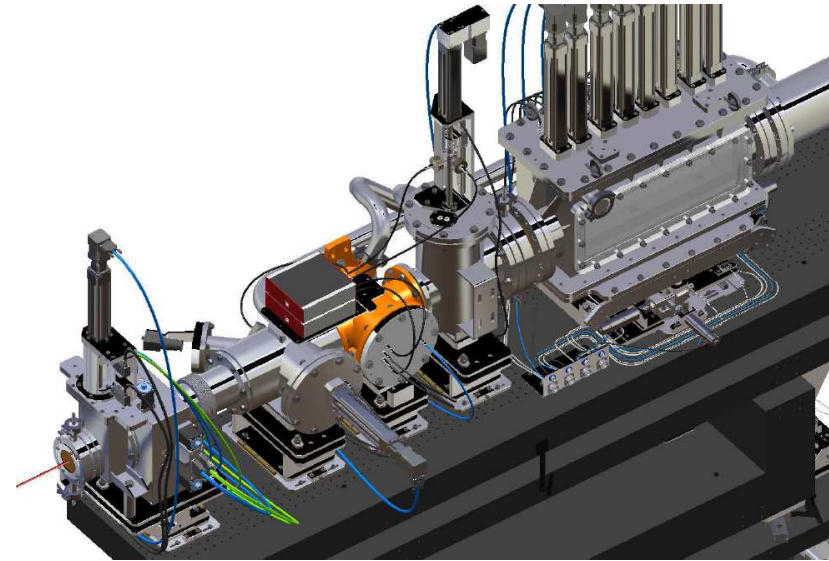


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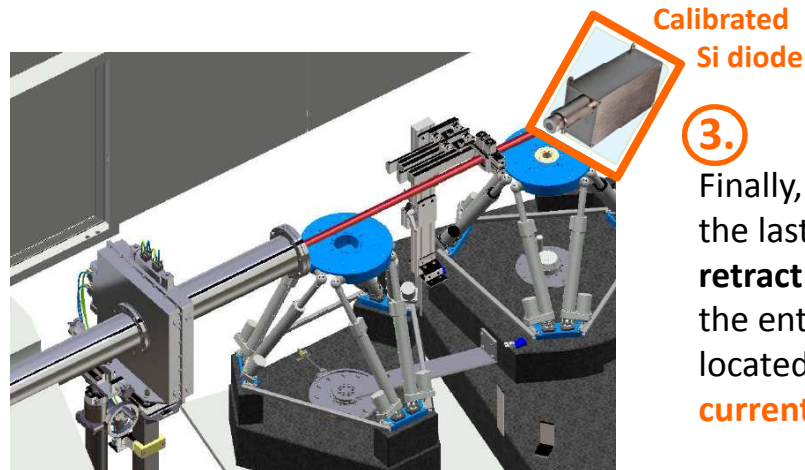
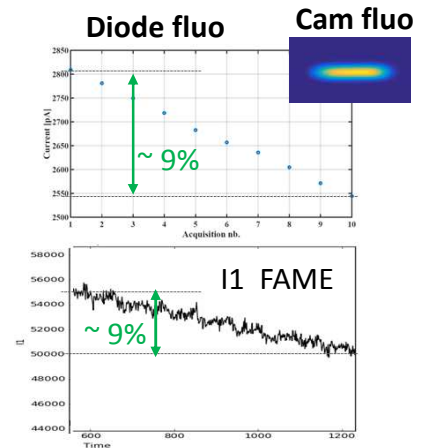
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3.

Finally, when e-/laser interactions will occur in **stable conditions**, the last phase will be to **measure the delivered total flux**: we will **retract the fluorescent screen**, select a **small given solid angle** with the entrance slits and measure the **current in the Si calibrated diode** located in the X-hutch. In the same time, we will follow the relative **currents in the “2-diodes detector”**.

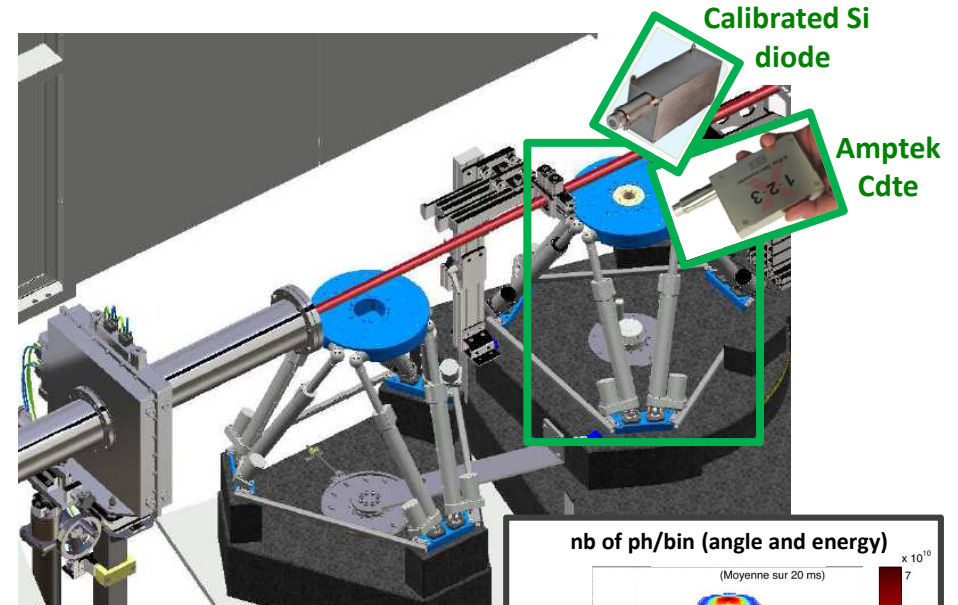
The basic commissioning is validated once the previous stages ①, ②, and ③ achieved,
... then, the following enters in the field of full-fledged physic analyses.

A.

Make the **characterization of the X-ray beam**:

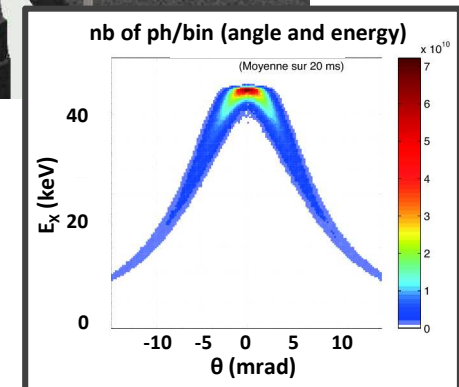
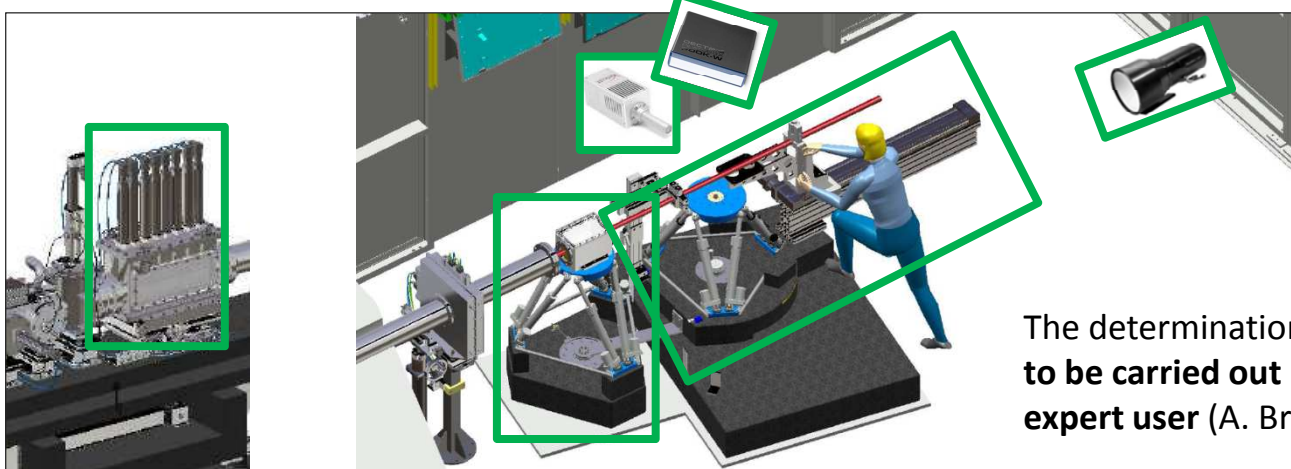
Scan the X-ray cone beam

- with the **CdTe detector** to measure the energy
 - and with the **calibrated diode** to measure the flux.
- The measured angular spectral flux and its broadening will be **correlated** with the **transverse emittance** and the **energy spread** of the **e- bunch**.



B.

Demonstration/user experiments



The determination of the **first experiments to be carried out** will be coordinated by an **expert user** (A. Bravin, ID17 ESRF).